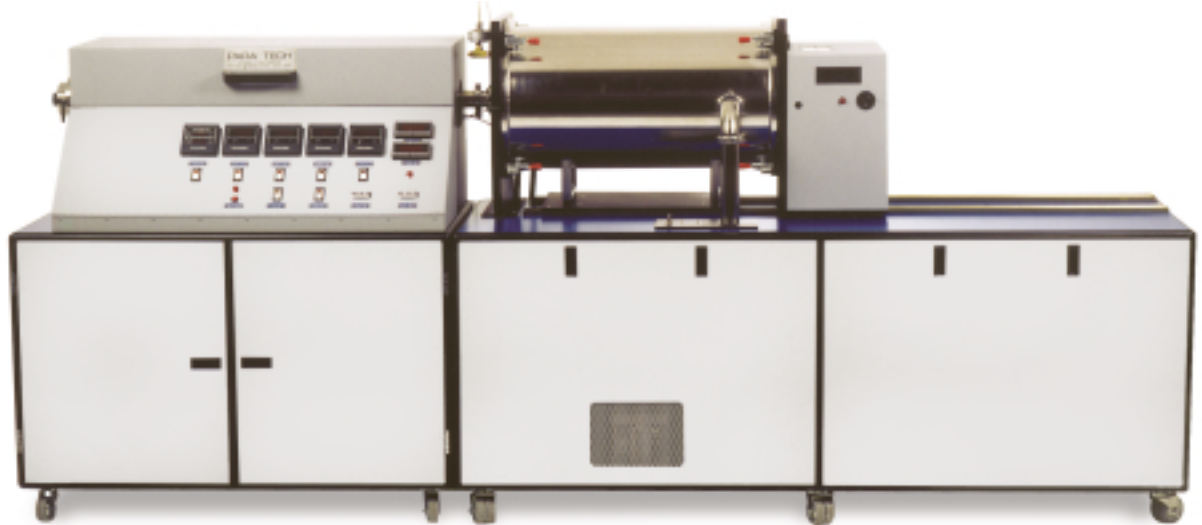


Parylene Deposition Systems

MODEL 2000H



Options

- Deposition module with different chamber size and configuration (vertical and horizontal).
- Host computer, to augment the standard micro-processor.
- Vacuum locks (blank off) for deposition module.
- Universal or custom fixtures.
- Clear plastic or Stainless steel lid with view port.
- Chart recorder.
- Spare parts kit.
- Alternative power configurations.

Features

LOW COST HIGHLY EFFICIENT, PATENTED VACUUM DEPOSITION SYSTEM

MODULAR CONSTRUCTION

CUSTOM CHAMBER SIZE

LOW WORKING HEIGHT

DIGITAL CONTROLS

BENCH HEIGHT CONTROLS & HINGED DOORS PERMIT EASY ACCESSIBILITY TO ALL COMPONENTS

AMPLE CABINET STORAGE

VACUUM PUMP EXHAUST FILTER

CASTER MOUNTED CABINETS

Benefits

Reduce parylene (Dimer) usage 10% to 12%.
Reduce set up time. Reduce cycle time.

Allows chamber size & configuration to be changed with negligible downtime.

Modular approach allows chamber to be tailored to ferrite size & quantity, thereby increasing efficiency.

4'-0" (1200 mm) chamber height allows easy and safe loading and unloading of substrates, hoists or step stools are not required.

Programmable, easily read, "high" reliability controllers.

Service and maintenance are simpler to perform, which reduces labor costs.

Store fixtures and material (Dimer) at point of use.

Eliminates expensive piped exhaust system.

Moving for service or loading/unloading is facilitated.

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Patent#4,945,856, #5,167,718, #5,268,033, #5,078,091, Other Patents Pending